

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES**

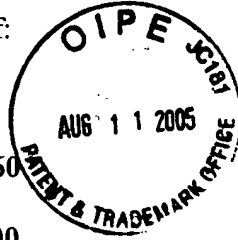
In re Patent Application of:

Morita, E.

Application No. 09/726,860

Filed: November 30, 2000

For: **METHOD OF MANUFACTURING
CRYSTAL OF III-V COMPOUND OF THE
NITRIDE SYSTEM, CRYSTAL
SUBSTRATE OF III-V COMPOUND OF
THE NITRIDE SYSTEM, CRYSTAL FILM
OF III-V COMPOUND OF THE NITRIDE
SYSTEM, AND METHOD OF
MANUFACTURING DEVICE**



Group Art Unit: 1765

Examiner: **Anderson, M. A.**

I hereby certify that this document is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 8, 2005.

Roxanne M. Swartz
Roxanne M. Swartz

PETITION TO WITHDRAW HOLDING OF ABANDONMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby petition to withdraw the holding of abandonment as set forth in the notice mailed by the Patent Office on July 12, 2005 in connection with the above-captioned application.

Submitted herewith is a copy of the Notice of Appeal previously filed with a Certificate of Mailing executed on July 8, 2005. Also, submitted herewith is a Request for Continued Examination (RCE) and Response to January 10, 2005 Final Office Action.

Please proceed with further examination of this application on the basis of the copies of the original papers filed.

The Commissioner is hereby authorized to charge any additional fees required, as well as any patent application processing fees associated with this communication for which full payment has not been tendered, to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.


Acknowledgement of the active status of this application is respectfully requested.

Respectfully submitted,

SONNENSCHN NATH & ROSENTHAL LLP

SONNENSCHN NATH & ROSENTHAL LLP
P.O. Box 061080
Wacker Drive Station
Sears Tower
Chicago, Illinois 60606-1080

By:



David Rozenblat
Registration No. 47,044

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Group Art Unit: 1765

Examiner: Anderson, M. A.

COPY

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Paula M. Theismann

Paula M. Theismann

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

NOTICE OF APPEAL

Dear Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the decision of the Examiner dated January 10, 2005, finally rejecting claims 1, 3-5 and 7-22. Pursuant to 37 C.F.R. § 1.17(b), the fee for this Notice of Appeal is \$500.00. A Petition for a 3 (three) month extension of time under 37 C.F.R. § 1.136(a) is enclosed. The fee for the extension is \$1020.00. Thus, a credit card form in the amount of \$1520.00 is enclosed.

The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Dated: July 8, 2005

By: 

David Rozenblat
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DOCKET NO. 9792909-4715

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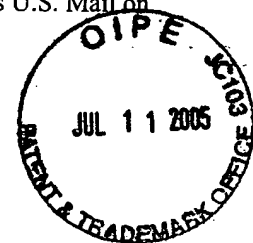
Patent Office Mail Room: Will you please affix the Patent Office stamp and return this card to acknowledge receipt of the following documents:

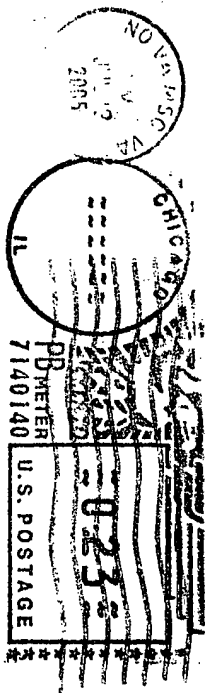
Applicant: Morita, E.
Serial No.: 09726,860
Filing Date: November 30, 2000
Client: Sony

Title: METHOD OF MANUFACTURING CRYSTAL OF III-V COMPOUND OF THE NITRIDE SYSTEM, CRYSTAL SUBSTRATE OF III-V COMPOUND OF THE NITRIDE SYSTEM, CRYSTAL FILM OF III-V COMPOUND OF THE NITRIDE SYSTEM, AND METHOD OF MANUFACTURING DEVICE

1. Notice of Appeal w/3 month extension of time(1 page – in duplicate)
2. Credit Card Payment Form 2038
3. Return receipt postcard

All mailed to the U.S. Patent and Trademark Office by first class U.S. Mail on July 8, 2005





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Dec 21 6:47

